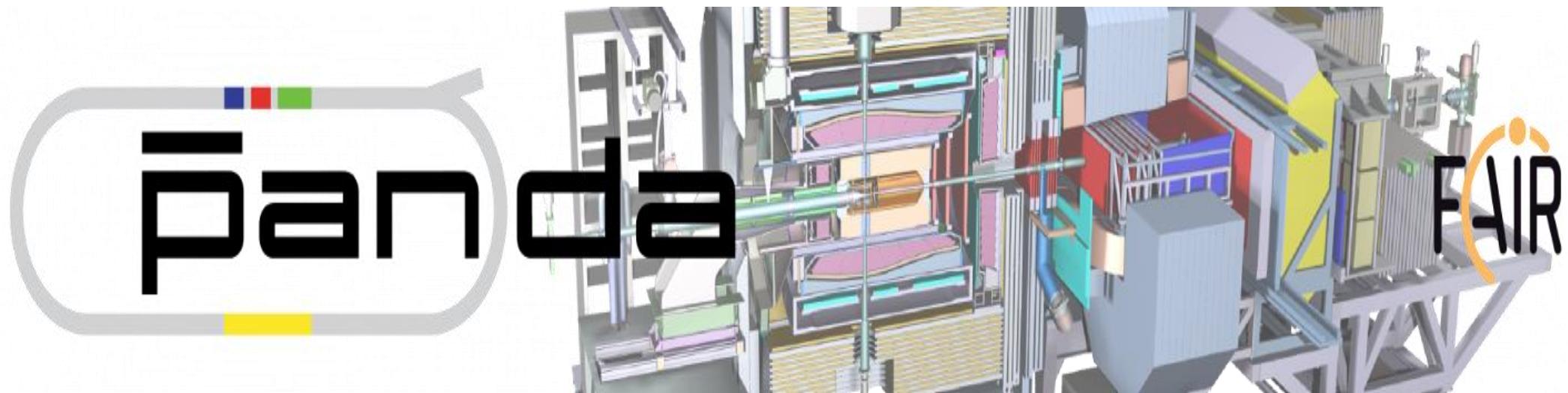


Sensor module assembly for the prototype of the PANDA Luminosity Detector

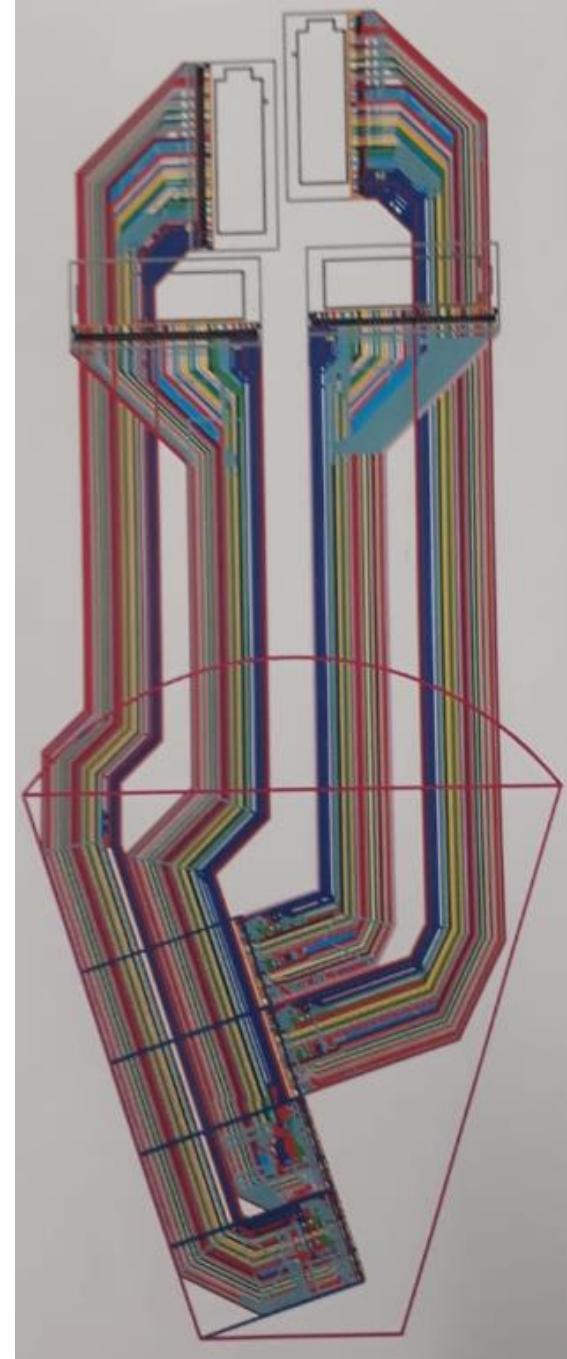
by Niels Boelger

15.06.2021



Prototype Sensor Modules

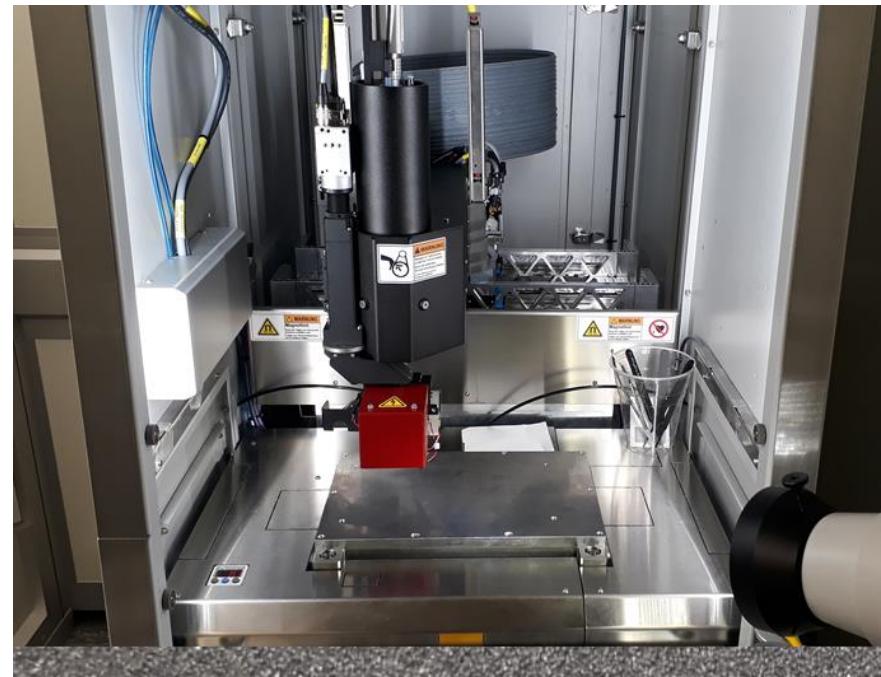
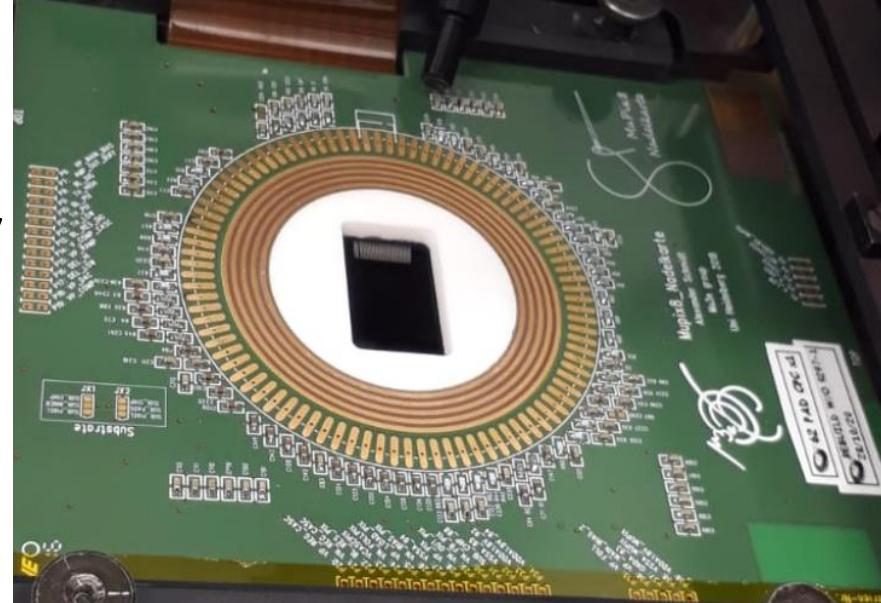
- 1 module formed by 4 MuPix Sensors on a diamond wafer
- Connection to readout via aluminum flex cables
- Getting the production process running: MuPix8
- Prototype Sensors: MuPix10

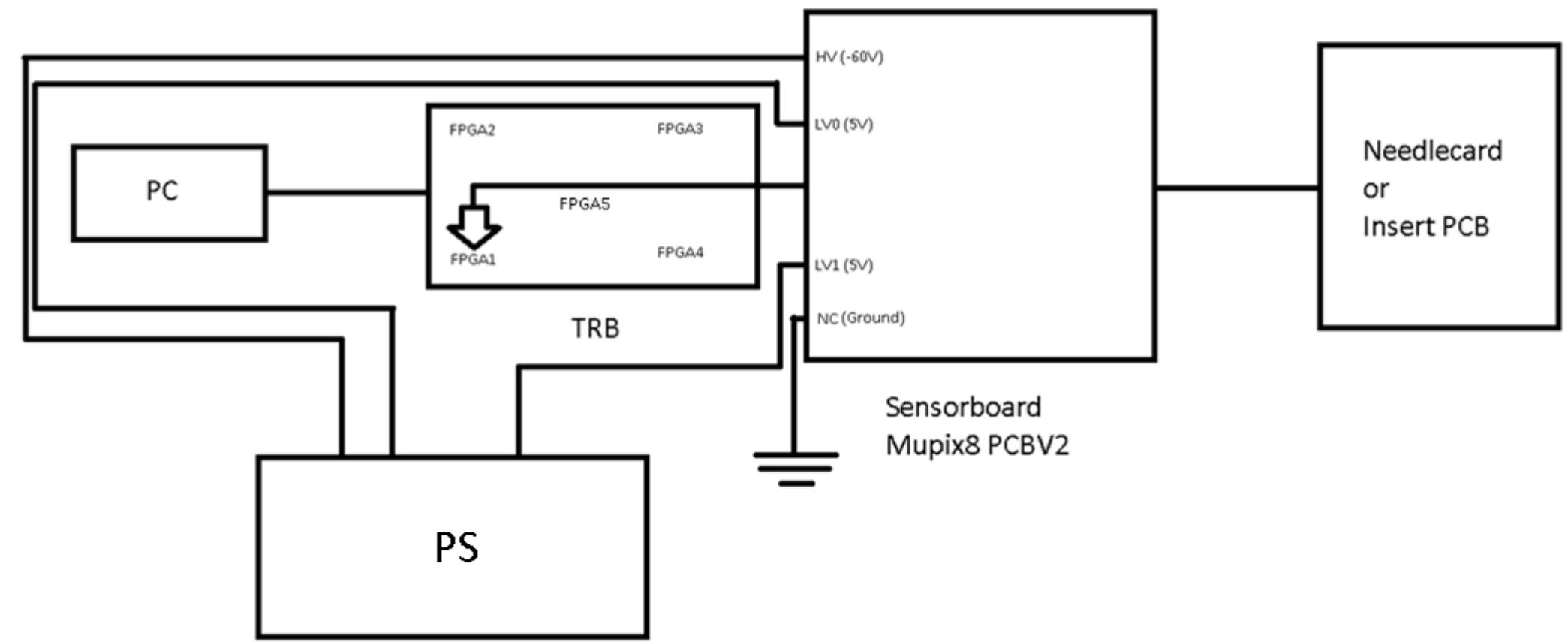


Sensor Module Assembly

Setting up a production process for sensor modules in our clean-room lab involves:

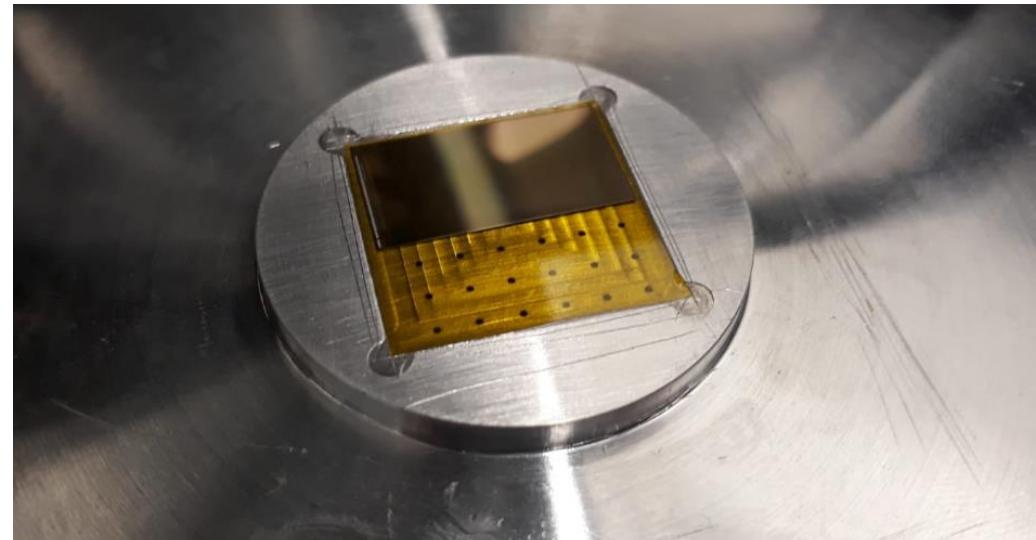
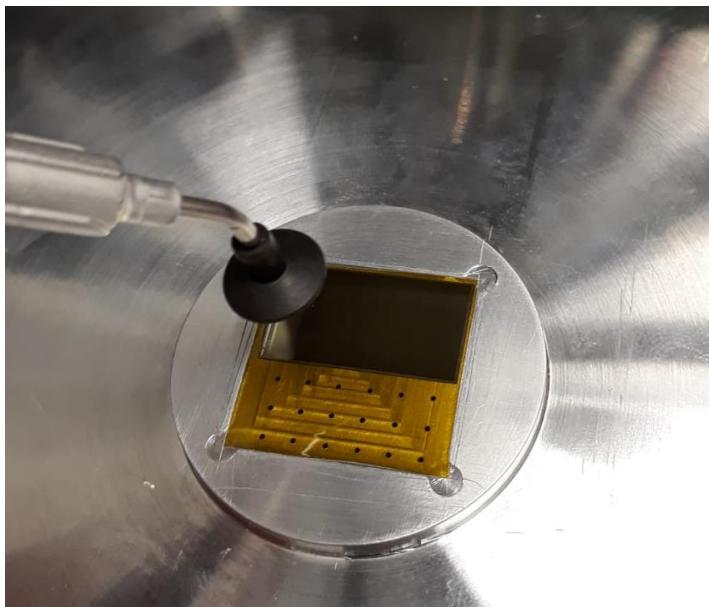
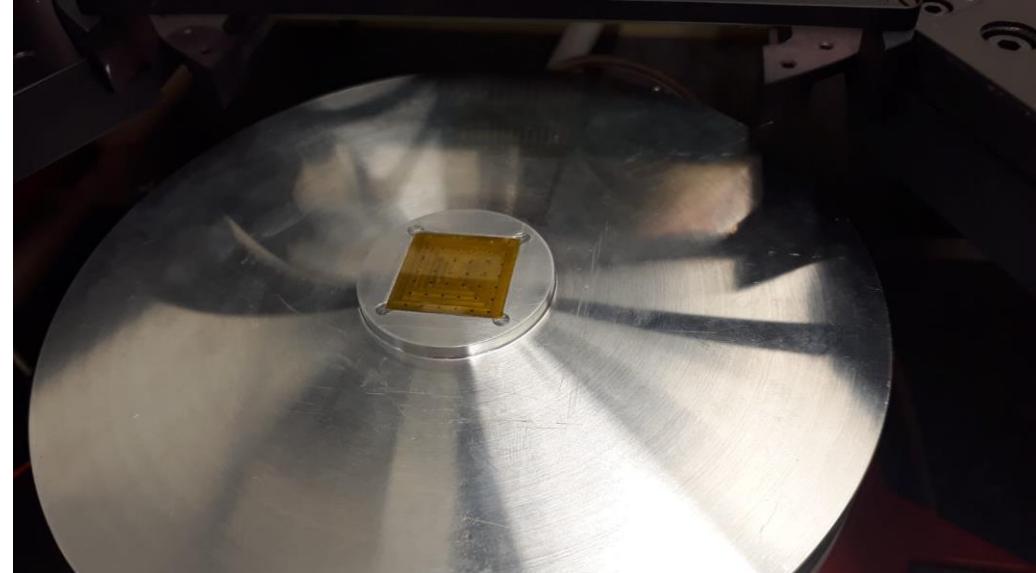
- Testing 26 MuPix8 (50 µm thickness) sensors from Heidelberg
- Evaluating and selecting best MuPix sensors
- Gathering experience with bonding, especially to TAB-bond MuPixels to flex cables
- Glueing bonded MuPixels on diamond wafers



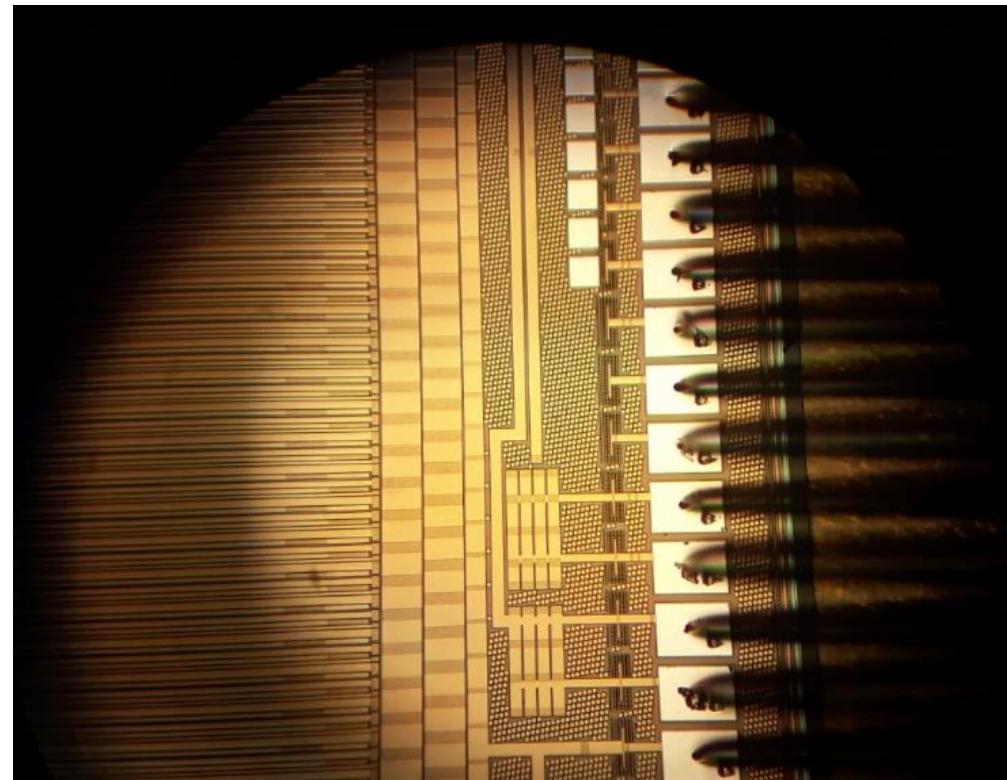
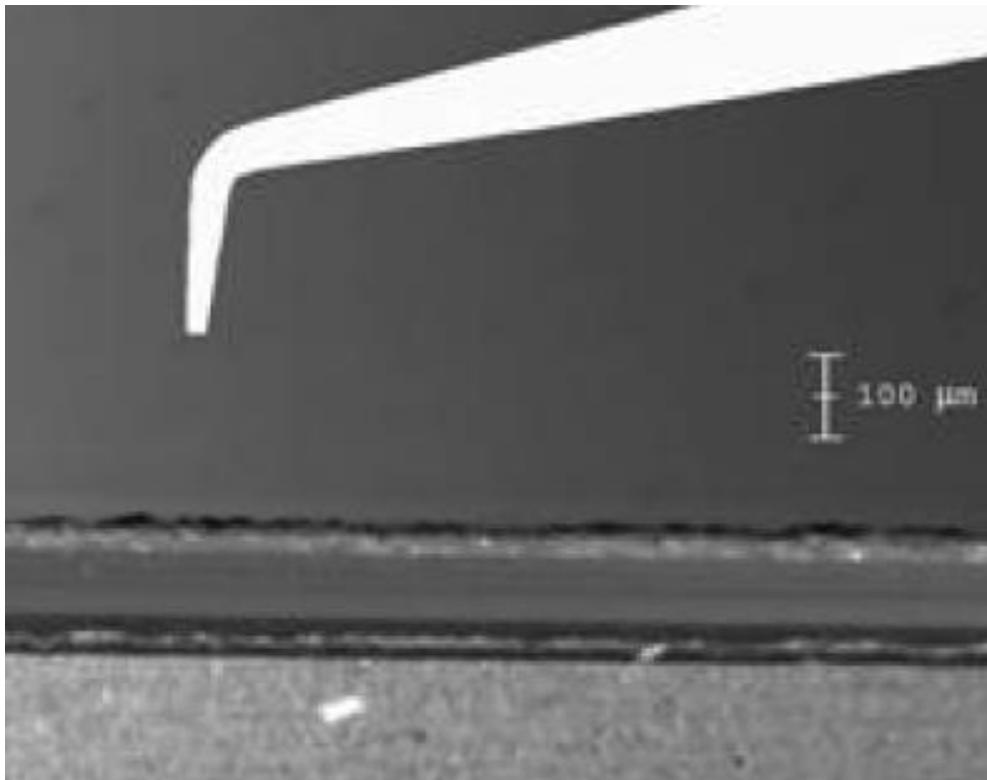


Probestation: Holder

- Isolated by 60 µm thick Kapton foil
- Vacuum applied through holes within the holder

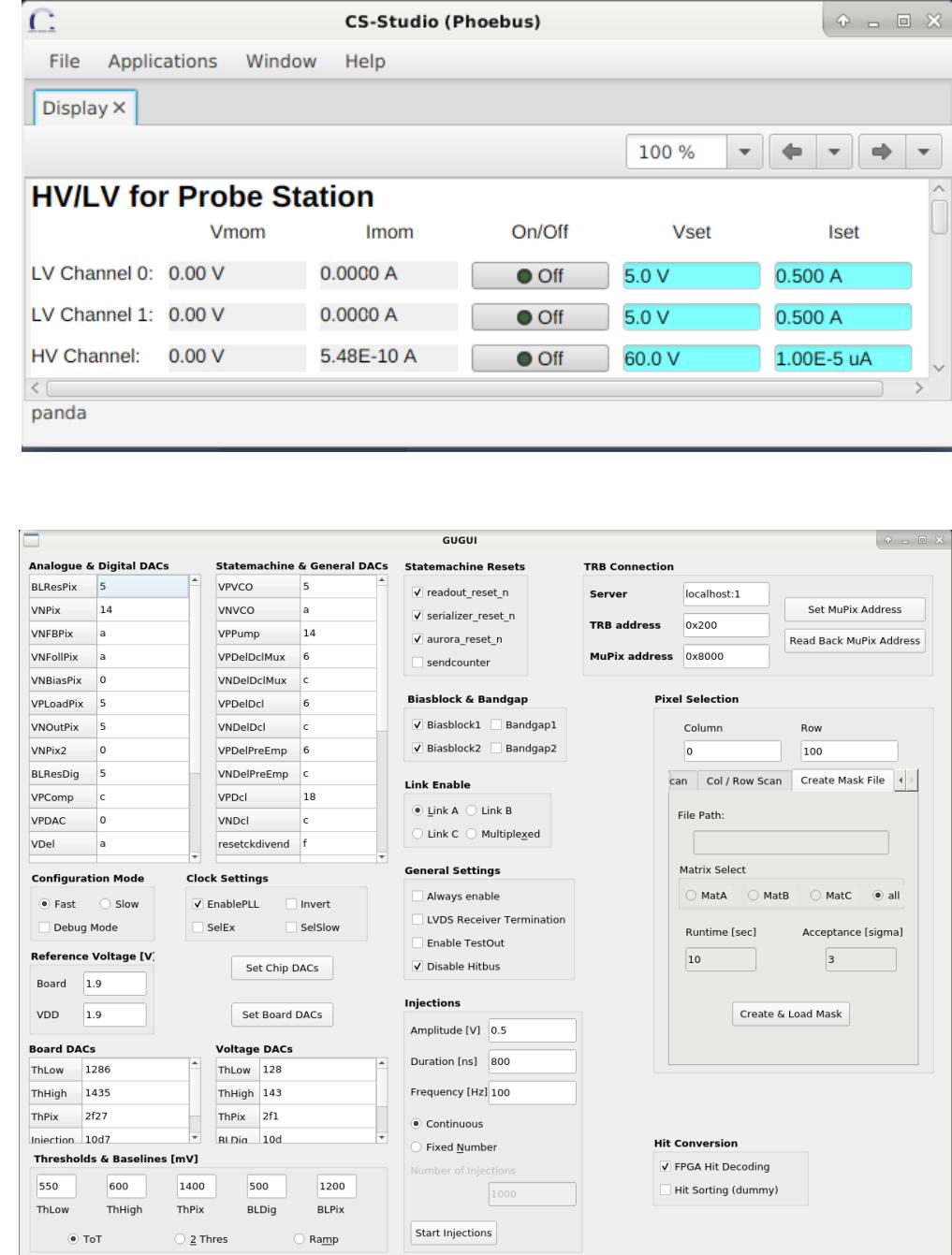


Applying needles to MuPix-Pads



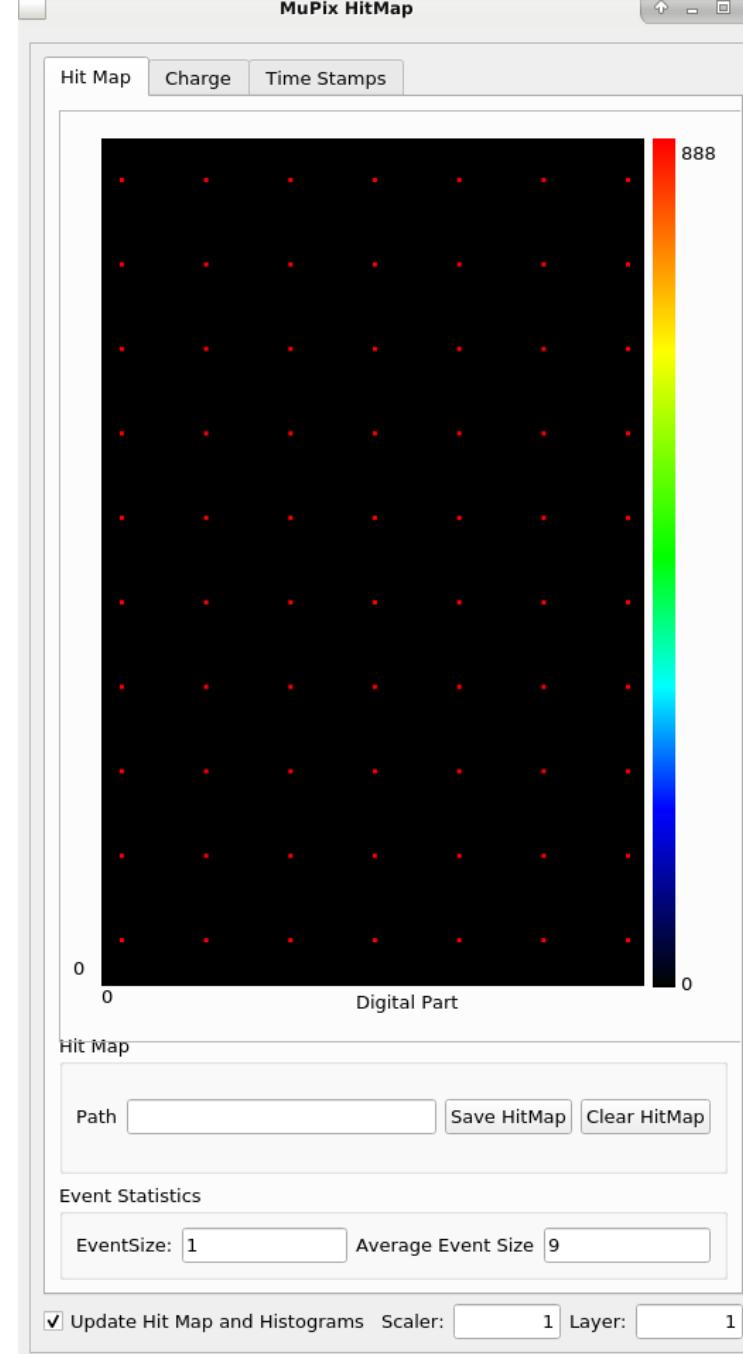
Software

- Phoebus: set voltages and currents
 - LV_0: Chip-electronics power supply
 - LV_1: Sensorboard power supply
 - HV: high reverse bias voltage (causing depletion layer)
- DAQ: configuration of MuPix DACs



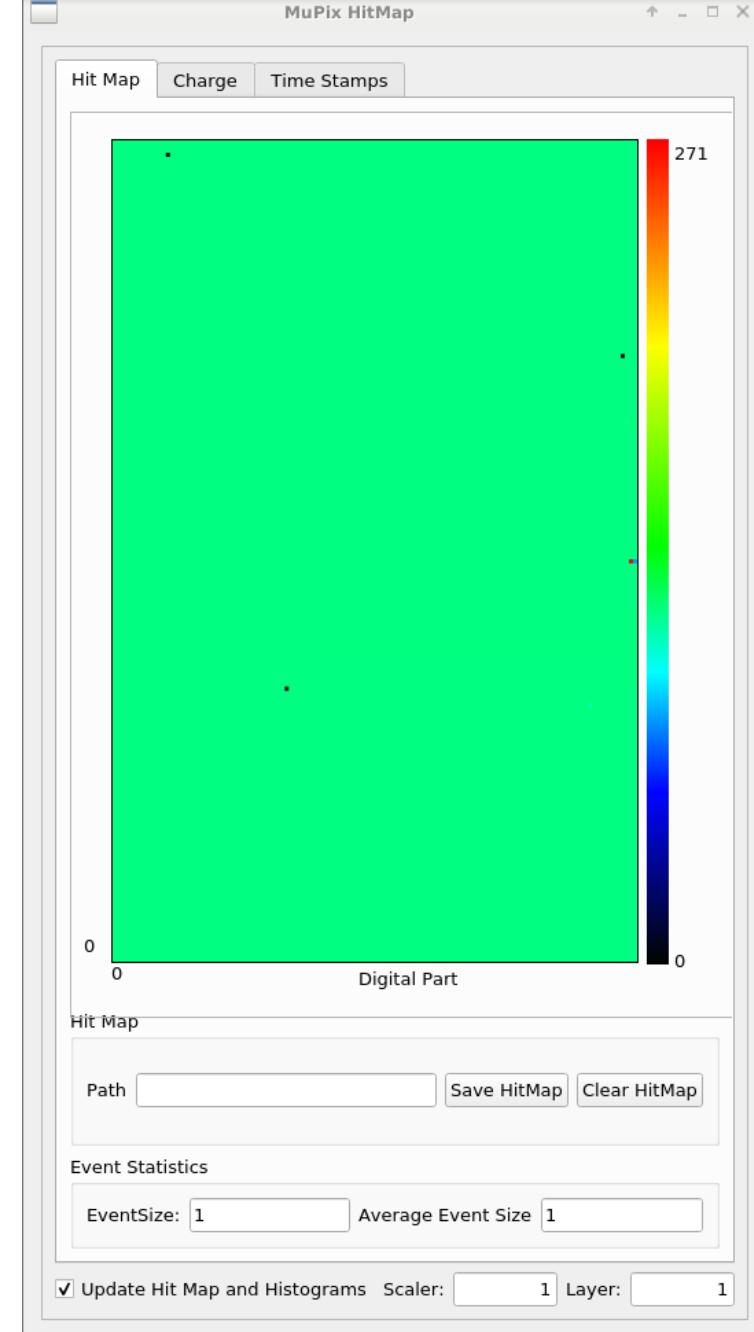
MuPix8 DAQ: Hitmap and injections

- Injection grid
- 70 pixels all over the sensor
- Used for s-curve measurements
 - Raising threshold until pixel stops to react to injections



MuPix8 DAQ: Hitmap and injections

- Pixelscan to find dead pixels
- Inject over whole sensor
- Impossible to inject every pixel at once



MuPix8 specs

- HV – 60V

Breakdown is definitely reached if the current exceeds 10 μ A

- Sensors vary in their maximum reachable HV, depending on their production batch

Sensors from older batches should be run at a maximum of 50 V

Chip: LV_0 (unset DACs): 70mA or slightly higher

LV_0 (set DACs): 380-400 mA

Board: LV_1 : 350 mA



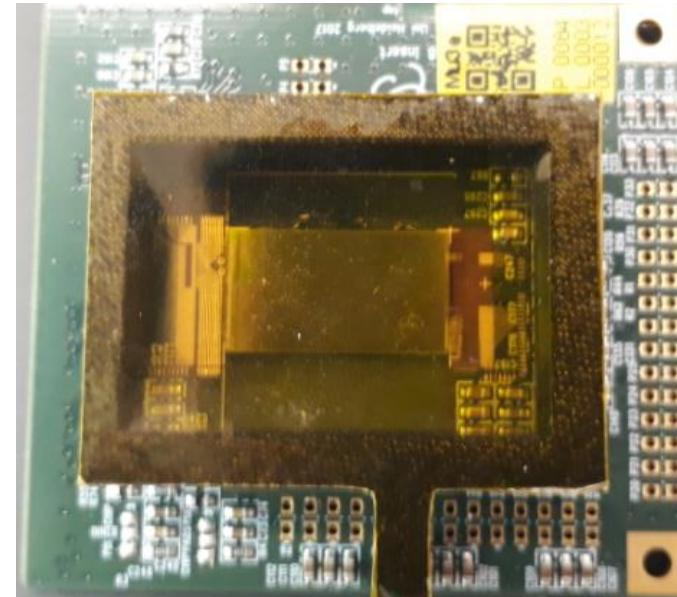
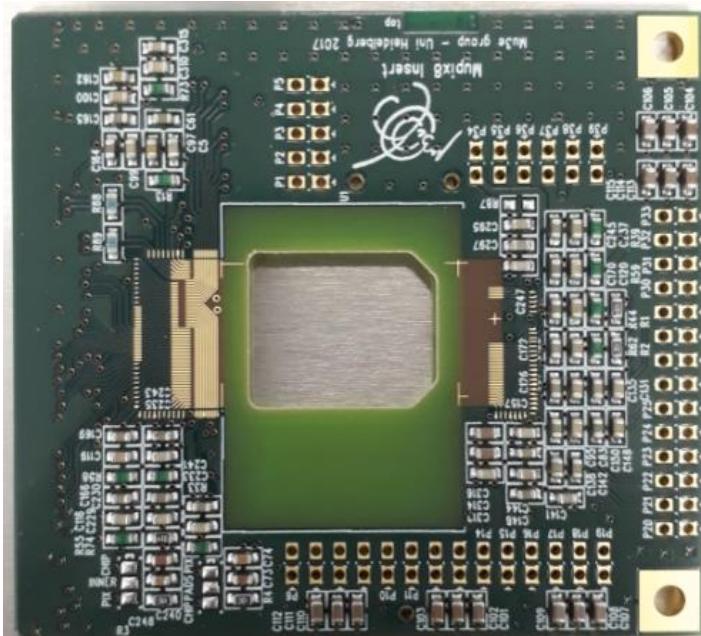
MuPix8 Production DB

Send

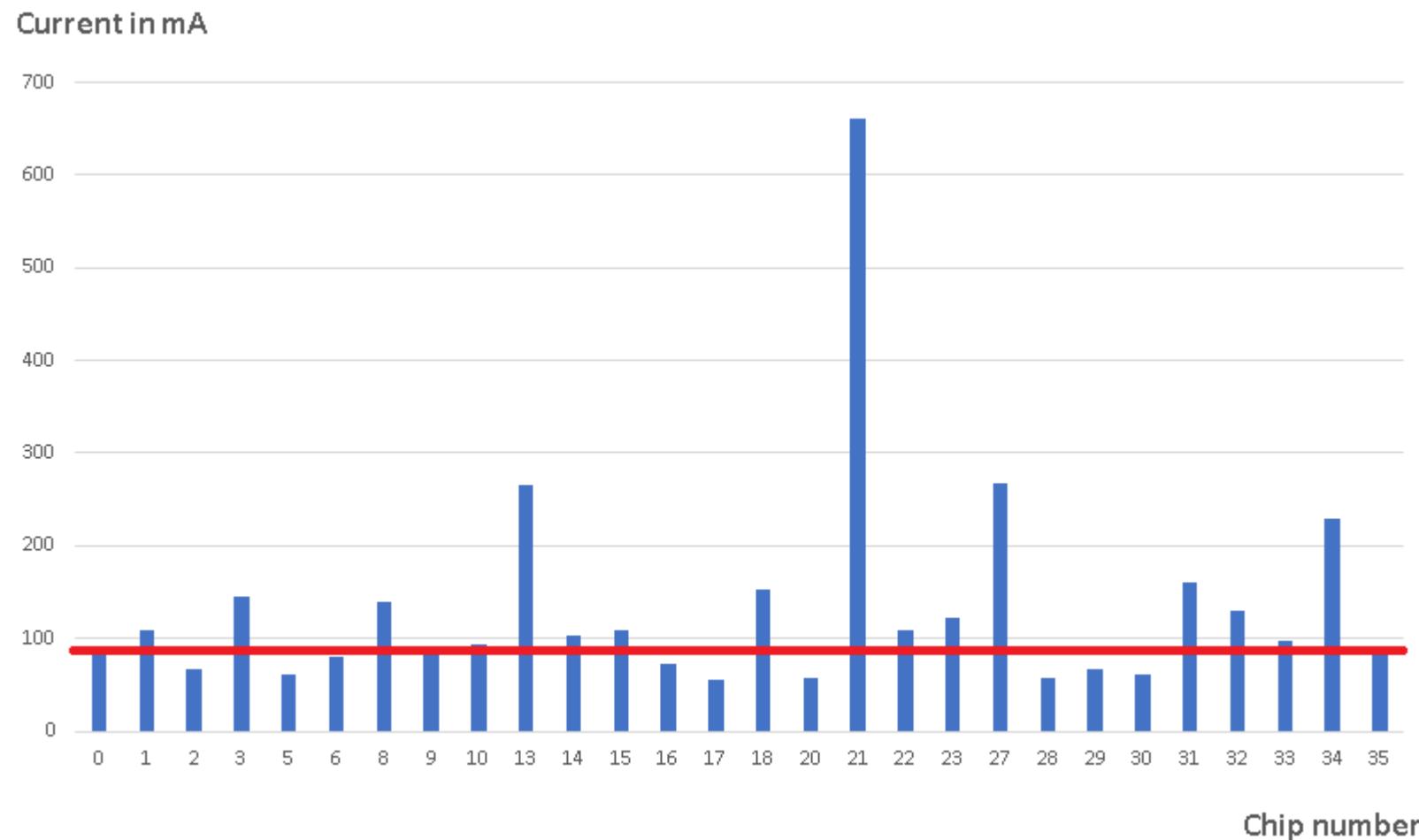
ID	MuPix ID	LV0 before [mA]	LV1 [mA]	HV before [V]	LV0 after [mA]	HV after [V]
1	0	87	324	50	367	50

Telescope MuPix8 bonded to Carrier

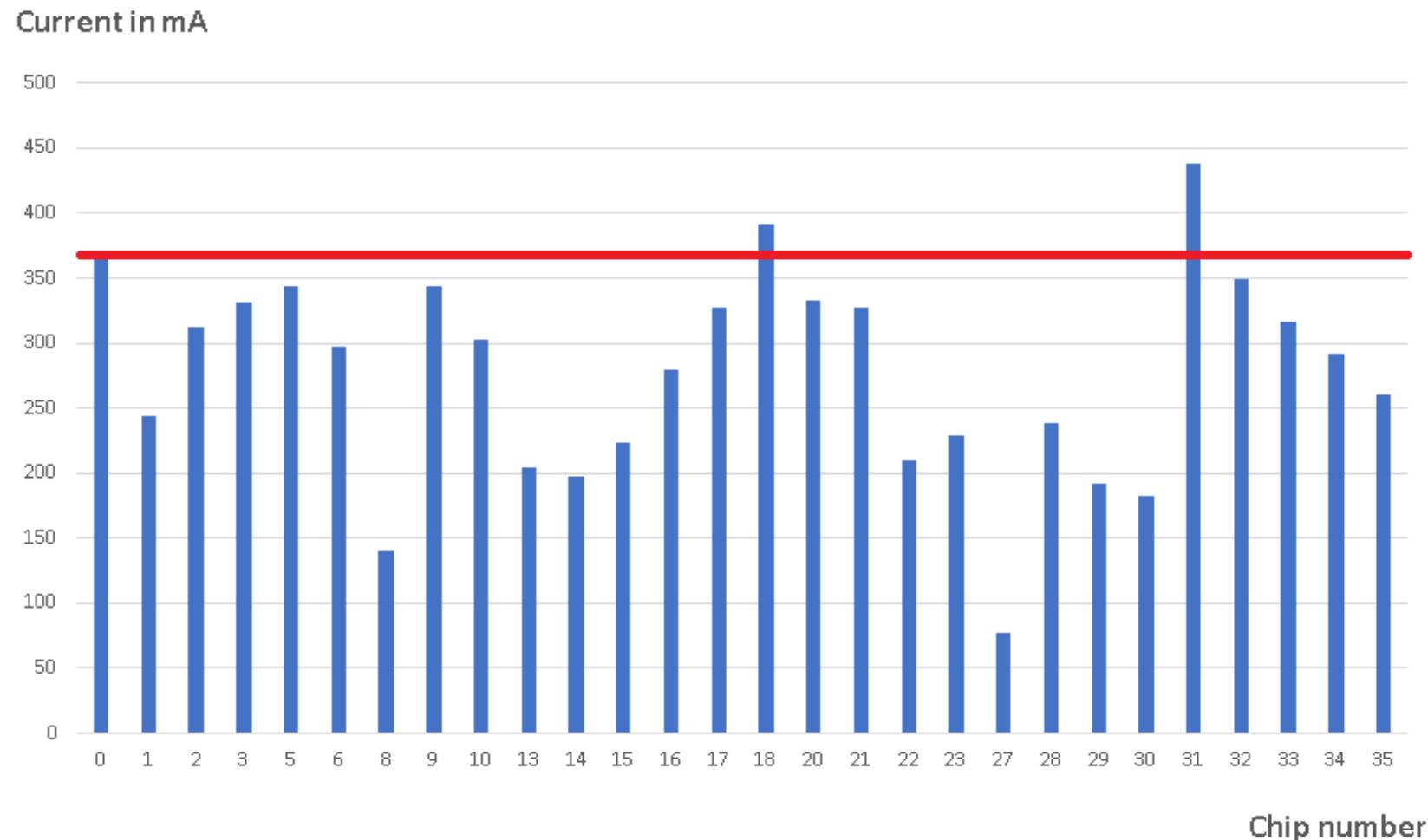
- Carrier: Insert PCB
- Reference Sensor 0 from Telescope with thickness of 625 µm



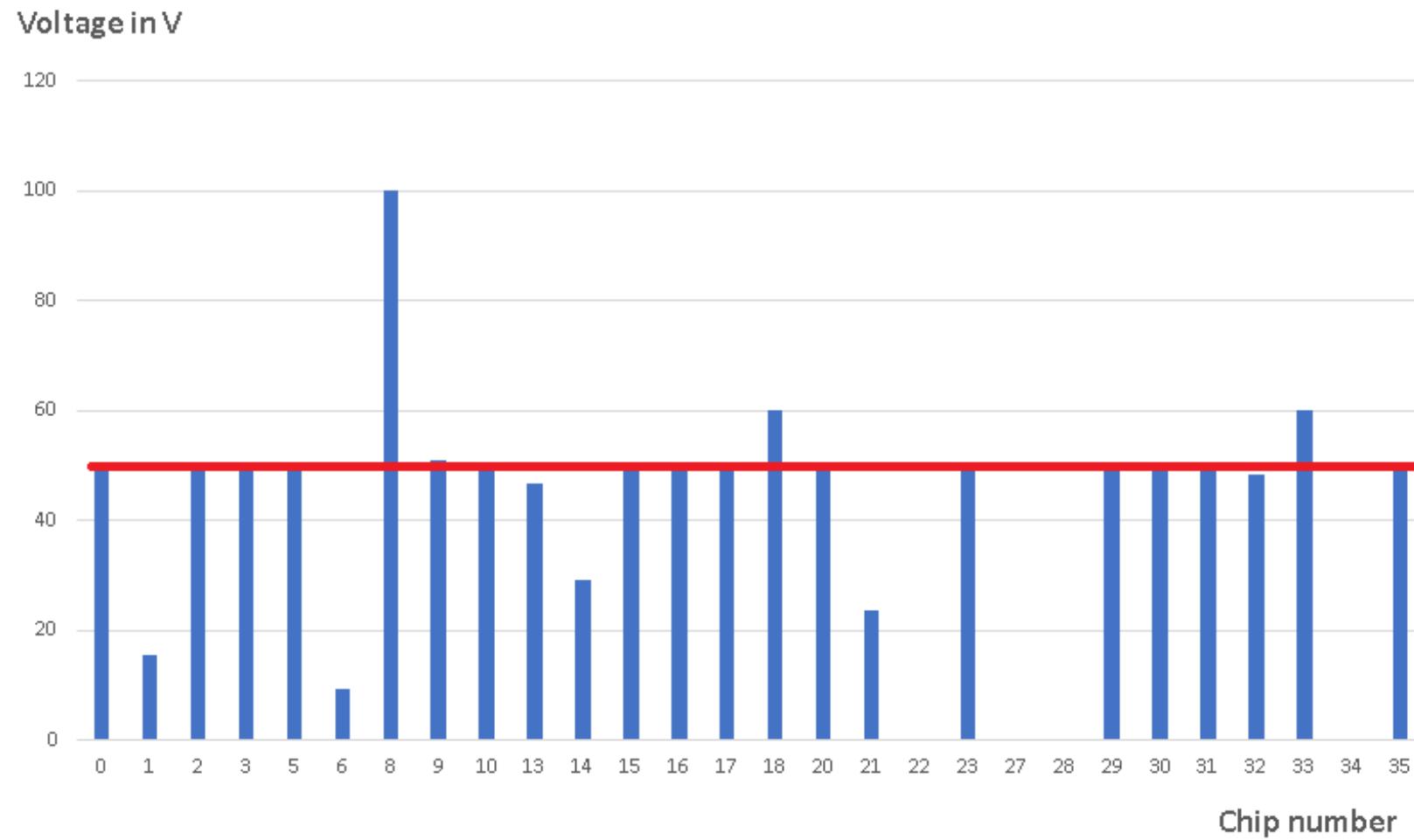
Results from MuPix8 tests: LV_0 DACs unset



Results from MuPix8 tests: LV_0 DACs set

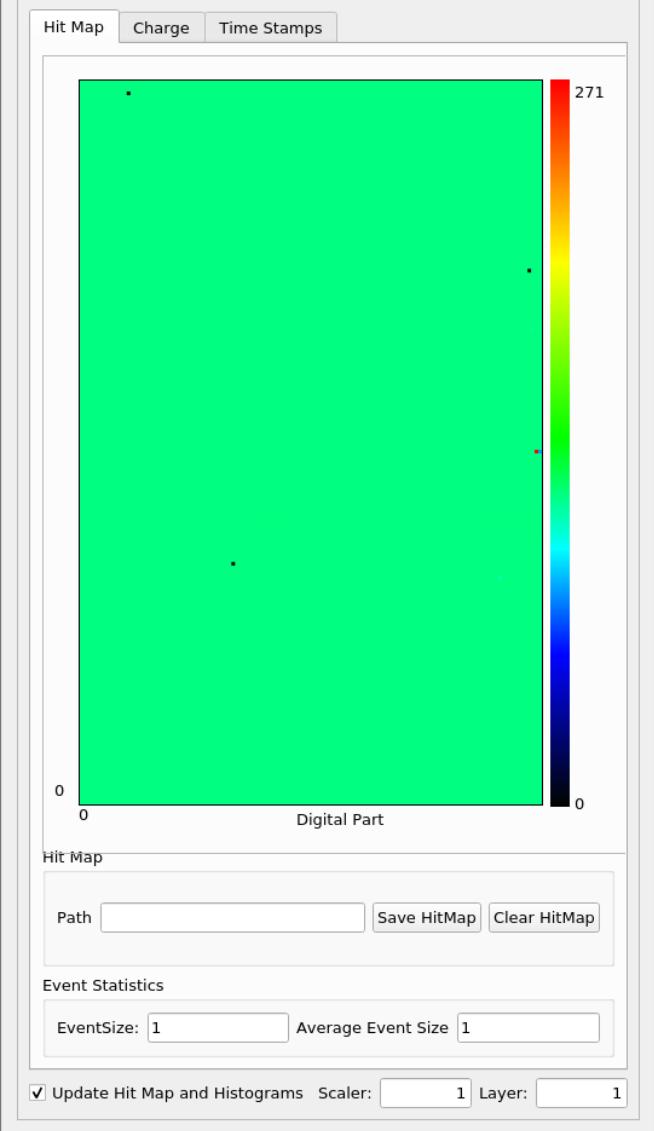


Results from MuPix8 tests: HV DACs set

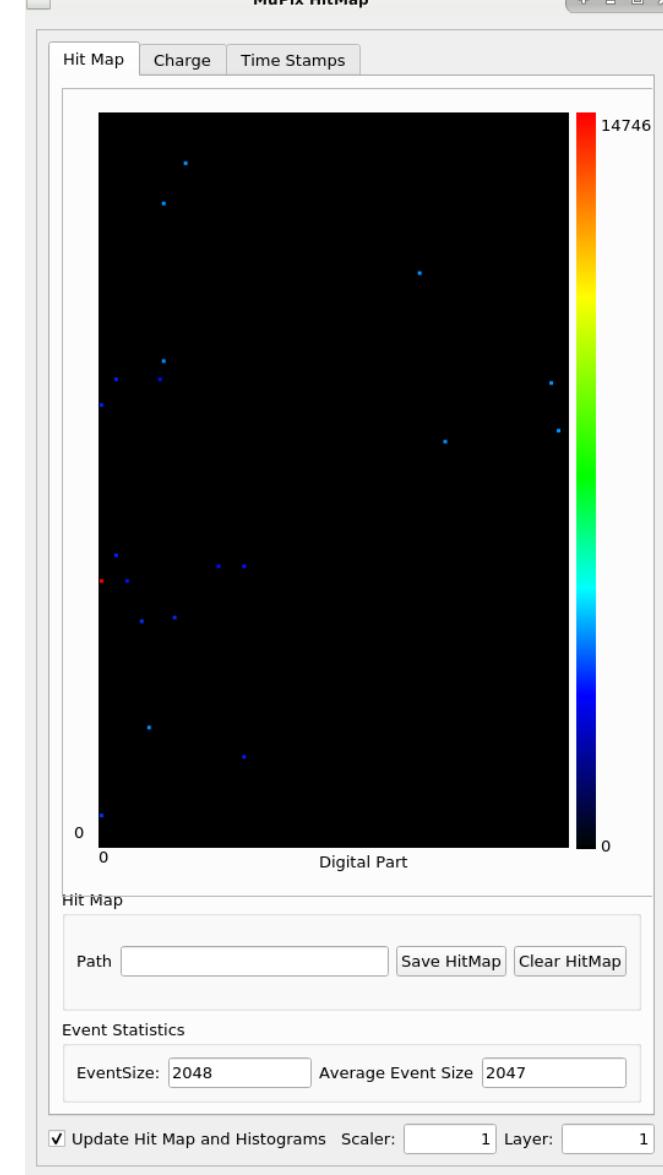


Results from MuPix8 tests

- Most sensors get a connection to the DAQ-system
 - About one half reacts to laserpointer
 - Only two react to injections
-
- Crosschecked results by:
 - Testing Referencesensor 0 with needlecard
=>injections became impossible, noisy (unmaskable) pixels and freezing hitmap
 - Testing Sensor 17 via carrier
=> works well
- =>Bad sensor behaviour is somehow related to needlecard, so just connect MuPix to cable and test one after another

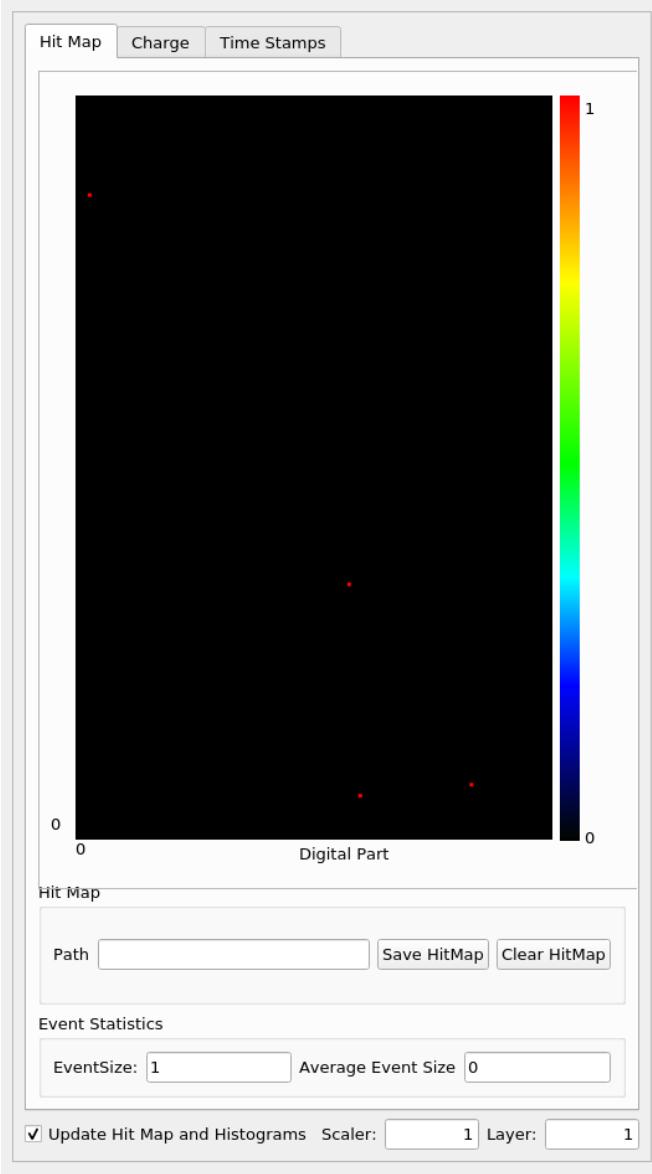


Sensor 0 PixelScan



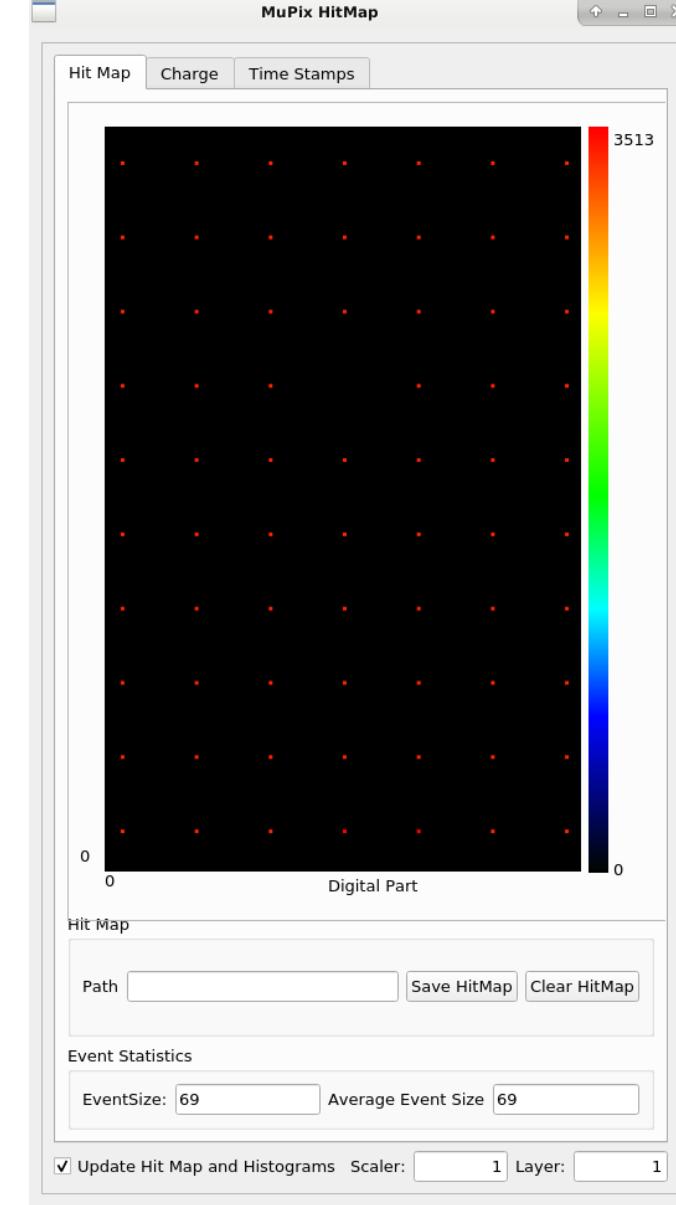
Connection via Carrier

Connection via needlecard



Sensor 17 Injections

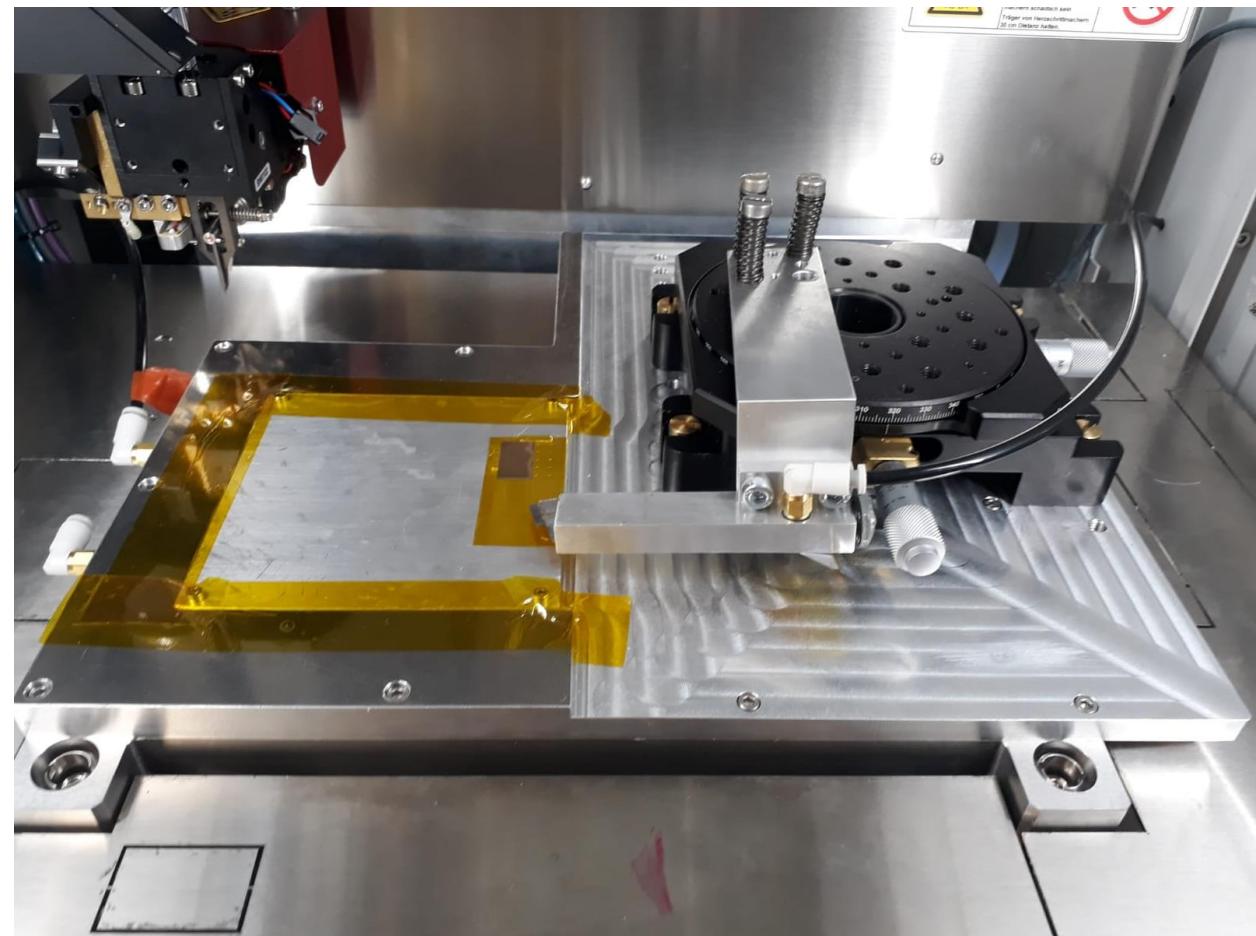
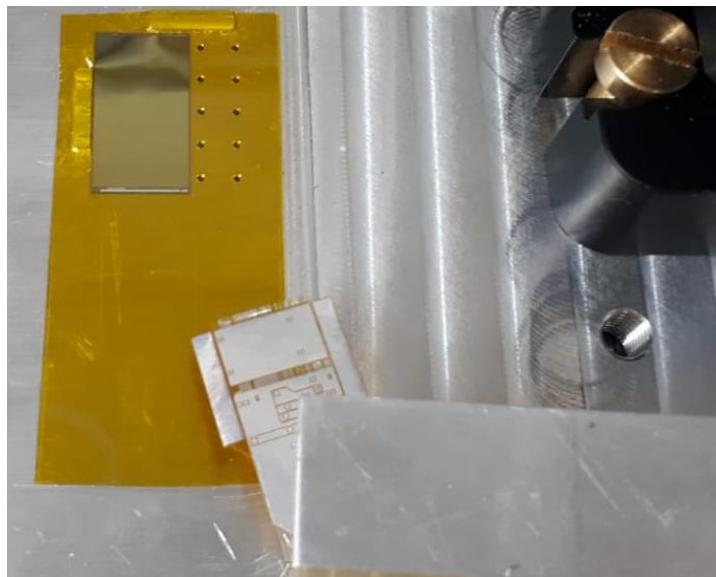
Connection via needocard



Connection via carrier

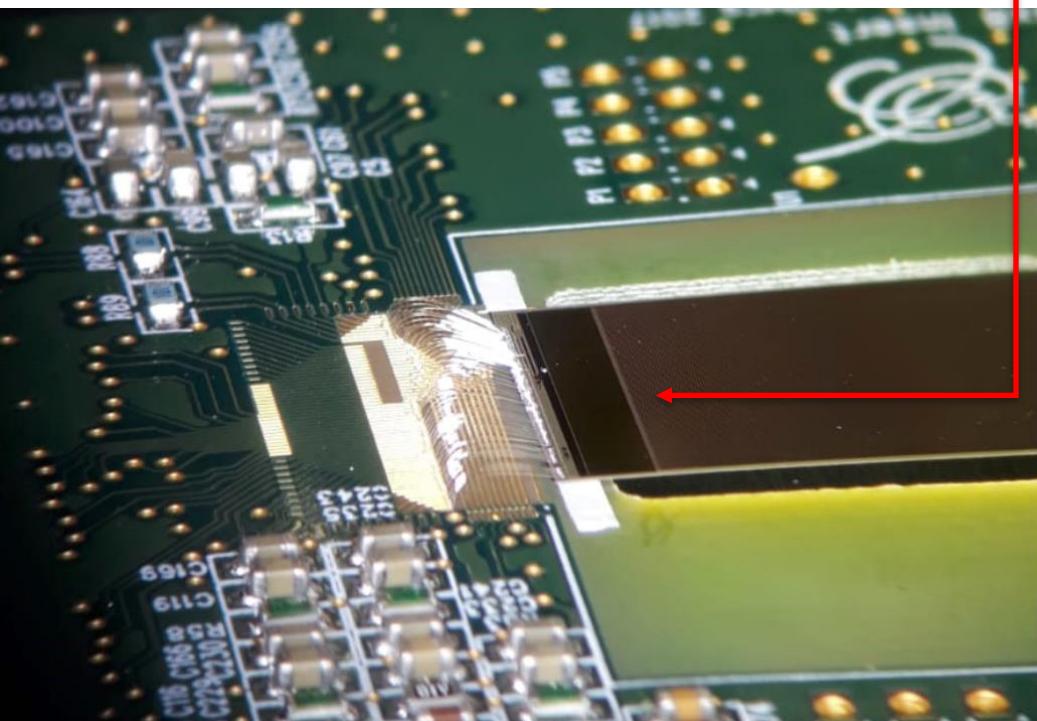
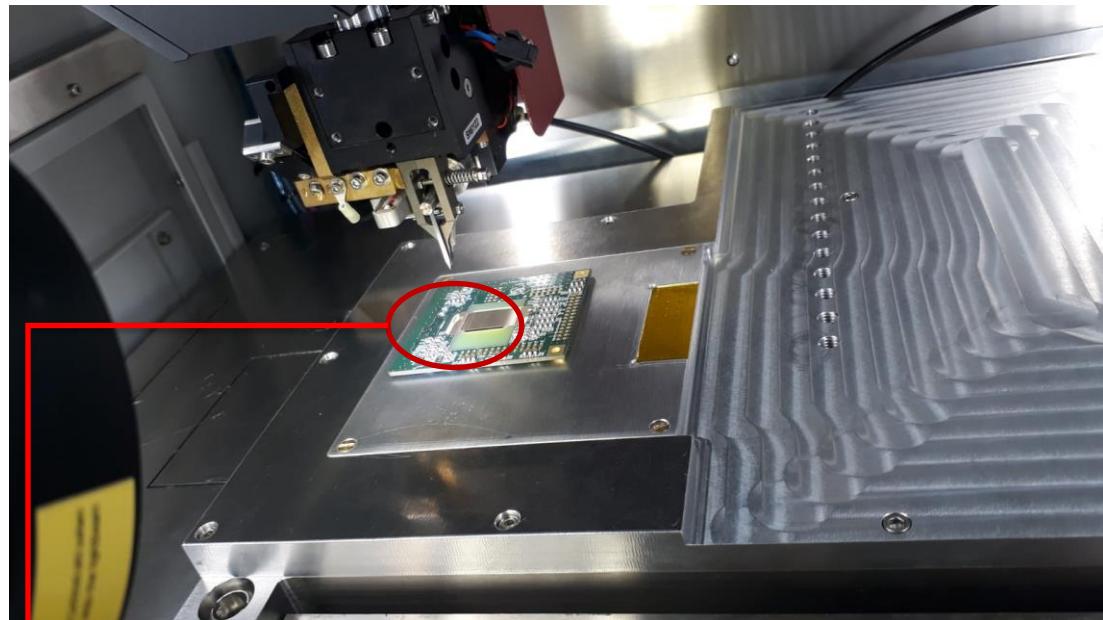
TAB-setup: MuPix to flex cables

- Vacuum arm allows precise positioning of flex cables above MuPix pads
- MuPix held in position by vacuum





Wirebonding Carrier



25 μm aluminum wire

Summary

- 26 Mupix8 were tested and not a single one is 100% working as intended (BUT reliable test?)
- Testing with needlecard shows hugh problems
- Bondingprocess works well, MuPix tested via Insert-PCBs show much more stable behaviour
- First Combination of MuPix8-Cables-Plug was produced

Outlook

- MuPix8s tab-bond to wire → improvement of measurements?
 - But Kintex-based DAQ is needed
- At least form 1 module out of 4 working sensors
- Glueing to diamond wafer
- Focus on MuPix10s: new flexcables, software etc.

Thank you for your attention!